

Title (en)

METHOD AND DEVICE FOR CONTINUOUSLY SUPPLYING A PRECURSOR

Title (de)

VERFAHREN UND VORRICHTUNG ZUR KONTINUIERLICHEN PRÄKURSorzUFÜHRUNG

Title (fr)

PROCÉDÉ ET DISPOSITIF D'ACHEMINEMENT EN CONTINU DE PRÉCURSEURS

Publication

EP 3137648 A1 20170308 (DE)

Application

EP 15720624 A 20150417

Priority

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Abstract (en)

[origin: WO2015165758A1] The invention relates to a method for supplying at least one precursor to a plurality of coating modules of a coating device and to a corresponding coating device, in particular a plasma coating device. The aim of the method is to provide a method and a simple device for coating, with which a precursor or precursors of a plurality of coating modules can be continuously provided with the same precursor level and a continuous coating operation is guaranteed, according to claim 1.

IPC 8 full level

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Citation (search report)

See references of WO 2015165758A1

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